



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Christoph Wasshuber, et al.

Docket No: TI-31016

Serial No: 10/020,111

Conf. No: 5837

Examiner: Richard A. Booth

Art Unit: 2812

Filed: 12/14/2001

For: METHODS AND APPARATUS FOR INDUCING STRESS IN A SEMICONDUCTOR  
DEVICE

AF/2800  
#8/Resp. NE  
3/15/3  
Sunder

AMENDMENT PURSUANT TO 37 CFR 1.116

Assistant Commissioner for Patents  
Washington, DC 20231

MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8(a)

I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231 on 5-6-03.

Ann Trent  
Ann Trent

Dear Sir:

Responsive to the Office Action mailed March 6, 2003, in connection with the  
above identified application, Applicants respectfully submit the following remarks.

RECEIVED  
MAY 12 2003  
TECHNOLOGY CENTER-800

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